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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 9516**

Norio KIMURA et al. : Docket No. 2003-0865

Serial No. 10/601,789 : Group Art Unit 3723

Filed June 24, 2003 : Examiner Hadi Shakeri

APPARATUS FOR POLISHING A
SUBSTRATE

RESPONSE UNDER 37. CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 3723.

AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of October 18, 2004, kindly amend the above-referenced
U.S. patent application as follows:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975